- SUBSTRATE
- 2. SURFACE S2 TO BE PARALLEL WITH SURFACE S1 TO WITHIN 5 arcsec

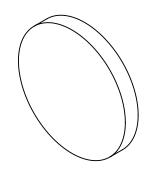
3. COATING (APPLY ACROSS COATING APERTURE)
S1: HARD DIELECTRIC SPUTTERED
T(avg): ≥91% FROM 408 - 1650nm @ 0° AOI
T(avg): ≤0.01% FROM 200 - 390nm @ 0° AOI
T(abs): =50% FOR 400±4nm @ 0° AOI

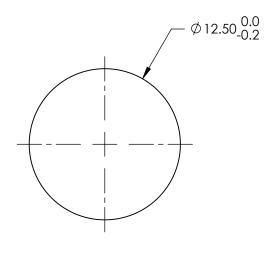
S2:SINGLE LAYER MgF2

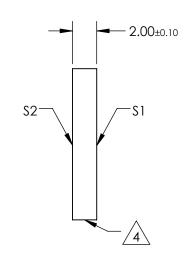
4. FINE GRIND SURFACE

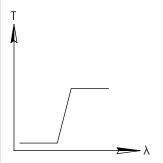
- 5. POWER, IRREGULARITY, AND SURFACE QUALITY SPECIFICATIONS APPLY ACROSS CLEAR APERTURE
- 6. TRANSMITTED WAVEFRONT DISTORTION, RMS: ≤λ/4 @ 633nm
- 7. ROHS COMPLIANT











LONGPASS FILTER

REV A	\$1	\$2
SHAPE	PLANO	PLANO
SURFACE QUALITY	40-20	40-20
CLEAR APERTURE	>80%	>80%
BEVEL	PROTECTIVE AS NEEDED	PROTECTIVE AS NEEDED

SPECIFICATIONS SUBJECT TO CHANGE WITHOUT NOTICE DIMENSIONS ARE FOR REFERENCE ONLY

)		•	
THIRD ANGLE PROJECTION	\rightarrow	TITLE	Ø12.5mm, 400nm, HIC LONGPASS		
ALL DIMS IN	mm	DWG NO	62974	SHEET 1 OF 1	

- SUBSTRATE
- 2. SURFACE S2 TO BE PARALLEL WITH SURFACE S1 TO WITHIN 5 arcsec

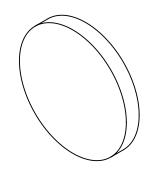
3. COATING (APPLY ACROSS COATING APERTURE)
S1: HARD DIELECTRIC SPUTTERED
T(avg): ≥91% FROM 458 - 1650nm @ 0° AOI
T(avg): ≤0.01% FROM 200 - 440nm @ 0° AOI
T(abs): =50% FOR 450±4.5nm @ 0° AOI

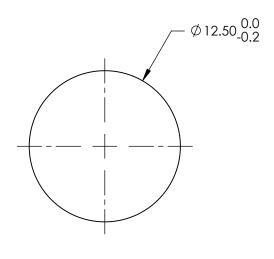
S2:SINGLE LAYER MgF2

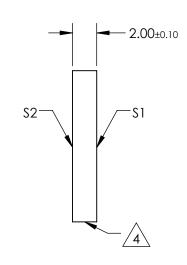
4. FINE GRIND SURFACE

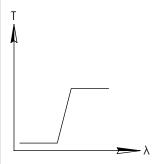
- 5. POWER, IRREGULARITY, AND SURFACE QUALITY SPECIFICATIONS APPLY ACROSS CLEAR APERTURE
- 6. TRANSMITTED WAVEFRONT DISTORTION, RMS: ≤\(\lambda/4\) @ 633nm
- 7. ROHS COMPLIANT











LONGPASS FILTER

REV A	\$1	\$2
SHAPE	PLANO	PLANO
SURFACE QUALITY	40-20	40-20
CLEAR APERTURE	>80%	>80%
BEVEL	PROTECTIVE AS NEEDED	PROTECTIVE AS NEEDED

SPECIFICATIONS SUBJECT TO CHANGE WITHOUT NOTICE DIMENSIONS ARE FOR REFERENCE ONLY

			-
THIRD ANGLE - PROJECTION		TITLE	Ø12.5mm, 450nm, HIGH PERFORMANCE LONGPASS FILTER
ALL DIMS IN	mm	DWG NO	62975 SHEET 1 OF 1

- SUBSTRATE
- 2. SURFACE S2 TO BE PARALLEL WITH SURFACE S1 TO WITHIN 5 arcsec

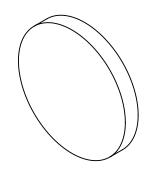
3. COATING (APPLY ACROSS COATING APERTURE)
S1: HARD DIELECTRIC SPUTTERED
T(avg): ≥91% FROM 508 - 1650nm @ 0° AOI
T(avg): ≤0.01% FROM 200 - 490nm @ 0° AOI
T(abs): =50% FOR 500±5nm @ 0° AOI

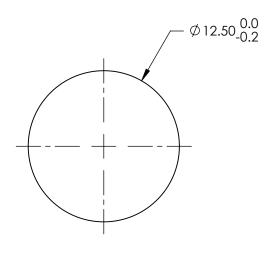
S2:SINGLE LAYER MgF2

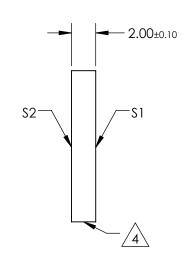
4. FINE GRIND SURFACE

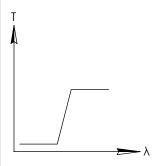
- 5. POWER, IRREGULARITY, AND SURFACE QUALITY SPECIFICATIONS APPLY ACROSS CLEAR APERTURE
- 6. TRANSMITTED WAVEFRONT DISTORTION, RMS: ≤λ/4 @ 633nm
- 7. ROHS COMPLIANT











LONGPASS FILTER

REV A	\$1	\$2
SHAPE	PLANO	PLANO
SURFACE QUALITY	40-20	40-20
CLEAR APERTURE	>80%	>80%
BEVEL	PROTECTIVE AS NEEDED	PROTECTIVE AS NEEDED

SPECIFICATIONS SUBJECT TO CHANGE WITHOUT NOTICE DIMENSIONS ARE FOR REFERENCE ONLY

THIRD ANGLE PROJECTION		TITLE	Ø12.5mm, 500nm, HIGH P LONGPASS FIL	CE
ALL DIMS IN	mm	DWG NO	62976	SHEET 1 OF 1

- SUBSTRATE
- 2. SURFACE S2 TO BE PARALLEL WITH SURFACE S1 TO WITHIN 5 arcsec

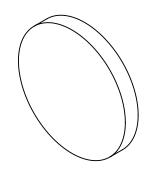
3. COATING (APPLY ACROSS COATING APERTURE)
S1: HARD DIELECTRIC SPUTTERED
T(avg): ≥91% FROM 560 - 1650nm @ 0° AOI
T(avg): ≤0.01% FROM 200 - 539nm @ 0° AOI
T(abs): =50% FOR 550±5.5nm @ 0° AOI

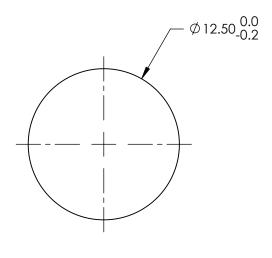
S2:SINGLE LAYER MgF2

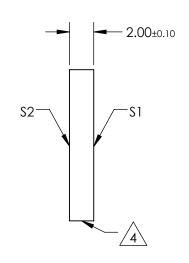
4. FINE GRIND SURFACE

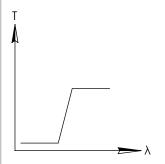
- 5. POWER, IRREGULARITY, AND SURFACE QUALITY SPECIFICATIONS APPLY ACROSS CLEAR APERTURE
- 6. TRANSMITTED WAVEFRONT DISTORTION, RMS: ≤\(\lambda/4\) @ 633nm
- 7. ROHS COMPLIANT











LONGPASS FILTER

REV A	\$1	\$2
SHAPE	PLANO	PLANO
SURFACE QUALITY	40-20	40-20
CLEAR APERTURE	>80%	>80%
BEVEL	PROTECTIVE AS NEEDED	PROTECTIVE AS NEEDED



			•
THIRD ANGLE _ PROJECTION		TITLE	Ø12.5mm, 550nm, HIGH PERFORMANCE LONGPASS FILTER
ALL DIMS IN	mm	DWG NO	62977 SHEET

- SUBSTRATE
- 2. SURFACE S2 TO BE PARALLEL WITH SURFACE S1 TO WITHIN 5 arcsec

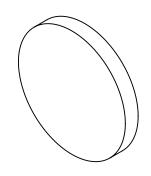
3. COATING (APPLY ACROSS COATING APERTURE)
S1: HARD DIELECTRIC SPUTTERED
T(avg): ≥91% FROM 610 - 1650nm @ 0° AOI
T(avg): ≤0.01% FROM 200 - 588nm @ 0° AOI
T(abs): =50% FOR 600±6nm @ 0° AOI

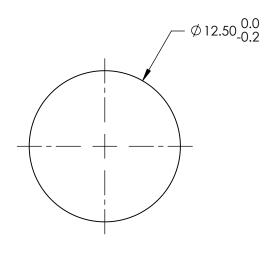
S2:SINGLE LAYER MgF2

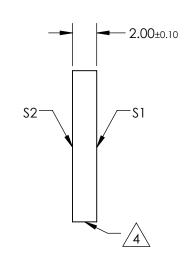
4. FINE GRIND SURFACE

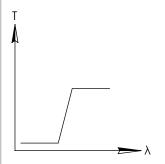
- 5. POWER, IRREGULARITY, AND SURFACE QUALITY SPECIFICATIONS APPLY ACROSS CLEAR APERTURE
- 6. TRANSMITTED WAVEFRONT DISTORTION, RMS: ≤\(\lambda/4\) @ 633nm
- 7. ROHS COMPLIANT











LONGPASS FILTER

REV A	\$1	\$2
SHAPE	PLANO	PLANO
SURFACE QUALITY	40-20	40-20
CLEAR APERTURE	>80%	>80%
BEVEL	PROTECTIVE AS NEEDED	PROTECTIVE AS NEEDED

SPECIFICATIONS SUBJECT TO CHANGE WITHOUT NOTICE DIMENSIONS ARE FOR REFERENCE ONLY

Ran® Edmund Optics®

THIRD ANGLE PROJECTION	ϕ	TITLE	Ø12.5mm, 600nm, HIGH PE LONGPASS FILTE	_	CE
ALL DIMS IN	mm	DWG NO	62978		SHEET 1 OF 1

- SUBSTRATE
- 2. SURFACE S2 TO BE PARALLEL WITH SURFACE S1 TO WITHIN 5 arcsec

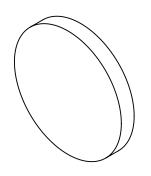
3. COATING (APPLY ACROSS COATING APERTURE)
S1: HARD DIELECTRIC SPUTTERED
T(avg): ≥91% FROM 660 - 1650nm @ 0° AOI
T(avg): ≤0.01% FROM 200 - 637nm @ 0° AOI
T(abs): =50% FOR 650±6.5nm @ 0° AOI

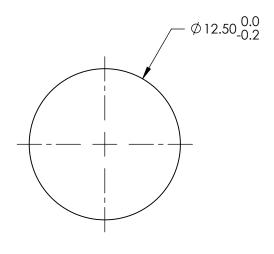
S2:SINGLE LAYER MgF2

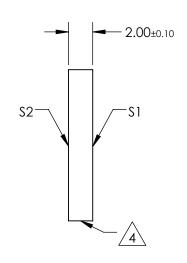
4. FINE GRIND SURFACE

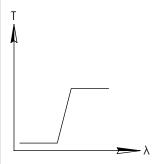
- 5. POWER, IRREGULARITY, AND SURFACE QUALITY SPECIFICATIONS APPLY ACROSS CLEAR APERTURE
- 6. TRANSMITTED WAVEFRONT DISTORTION, RMS: ≤λ/4 @ 633nm
- 7. ROHS COMPLIANT











LONGPASS FILTER

REV A	\$1	\$2
SHAPE	PLANO	PLANO
SURFACE QUALITY	40-20	40-20
CLEAR APERTURE	>80%	>80%
BEVEL	PROTECTIVE AS NEEDED	PROTECTIVE AS NEEDED



THIRD ANGLE - PROJECTION	\rightarrow	TITLE	Ø12.5mm, 650nm, HIGH PERFORMANCE LONGPASS FILTER	
ALL DIMS IN	mm	DWG NO	62979 SHEE	T

- SUBSTRATE
- 2. SURFACE S2 TO BE PARALLEL WITH SURFACE S1 TO WITHIN 5 arcsec

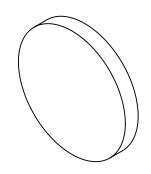
3. COATING (APPLY ACROSS COATING APERTURE)
S1: HARD DIELECTRIC SPUTTERED
T(avg): ≥91% FROM 765 - 1650nm @ 0° AOI
T(avg): ≤0.01% FROM 200 - 735nm @ 0° AOI
T(abs): =50% FOR 750±7.5nm @ 0° AOI

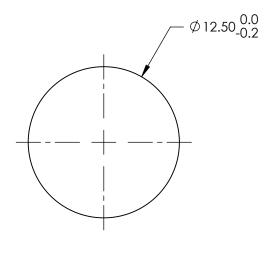
S2:SINGLE LAYER MgF2

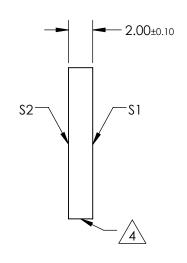
4. FINE GRIND SURFACE

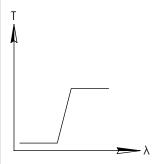
- 5. POWER, IRREGULARITY, AND SURFACE QUALITY SPECIFICATIONS APPLY ACROSS CLEAR APERTURE
- 6. TRANSMITTED WAVEFRONT DISTORTION, RMS: ≤\(\lambda/4\) @ 633nm
- 7. ROHS COMPLIANT











LONGPASS FILTER

REV A	\$1	\$2
SHAPE	PLANO	PLANO
SURFACE QUALITY	40-20	40-20
CLEAR APERTURE	>80%	>80%
BEVEL	PROTECTIVE AS NEEDED	PROTECTIVE AS NEEDED

SPECIFICATIONS SUBJECT TO CHANGE WITHOUT NOTICE DIMENSIONS ARE FOR REFERENCE ONLY

			•
THIRD ANGLE _ PROJECTION		TITLE	Ø12.5mm, 750nm, HIGH PERFORMANCE LONGPASS FILTER
ALL DIMS IN	mm	DWG NO	66226 SHEET

- SUBSTRATE
- 2. SURFACE S2 TO BE PARALLEL WITH SURFACE S1 TO WITHIN 5 arcsec

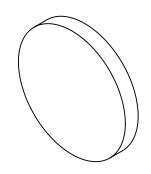
3. COATING (APPLY ACROSS COATING APERTURE)
S1: HARD DIELECTRIC SPUTTERED
T(avg): ≥91% FROM 765 - 1650nm @ 0° AOI
T(avg): ≤0.01% FROM 200 - 735nm @ 0° AOI
T(abs): =50% FOR 750±7.5nm @ 0° AOI

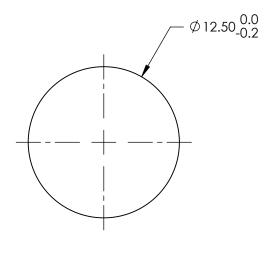
S2:SINGLE LAYER MgF2

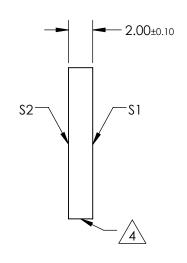
4. FINE GRIND SURFACE

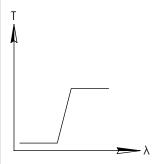
- 5. POWER, IRREGULARITY, AND SURFACE QUALITY SPECIFICATIONS APPLY ACROSS CLEAR APERTURE
- 6. TRANSMITTED WAVEFRONT DISTORTION, RMS: ≤\(\lambda/4\) @ 633nm
- 7. ROHS COMPLIANT











LONGPASS FILTER

REV A	\$1	\$2
SHAPE	PLANO	PLANO
SURFACE QUALITY	40-20	40-20
CLEAR APERTURE	>80%	>80%
BEVEL	PROTECTIVE AS NEEDED	PROTECTIVE AS NEEDED

SPECIFICATIONS SUBJECT TO CHANGE WITHOUT NOTICE DIMENSIONS ARE FOR REFERENCE ONLY

			•
THIRD ANGLE _ PROJECTION		TITLE	Ø12.5mm, 750nm, HIGH PERFORMANCE LONGPASS FILTER
ALL DIMS IN	mm	DWG NO	66226 SHEET

- SUBSTRATE
- 2. SURFACE S2 TO BE PARALLEL WITH SURFACE S1 TO WITHIN 5 arcsec

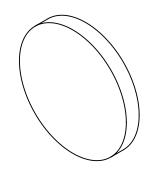
3. COATING (APPLY ACROSS COATING APERTURE)
S1: HARD DIELECTRIC SPUTTERED
T(avg): ≥91% FROM 815 - 1650nm @ 0° AOI
T(avg): ≤0.01% FROM 200 - 785nm @ 0° AOI
T(abs): =50% FOR 800±8nm @ 0° AOI

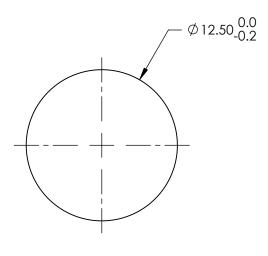
S2:SINGLE LAYER MgF2

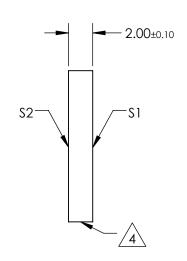
4. FINE GRIND SURFACE

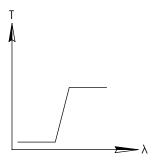
- 5. POWER, IRREGULARITY, AND SURFACE QUALITY SPECIFICATIONS APPLY ACROSS CLEAR APERTURE
- 6. TRANSMITTED WAVEFRONT DISTORTION, RMS: ≤λ/4 @ 633nm
- 7. ROHS COMPLIANT











LONGPASS FILTER

REV A	\$1	\$2
SHAPE	PLANO	PLANO
SURFACE QUALITY	40-20	40-20
CLEAR APERTURE	>80%	>80%
BEVEL	PROTECTIVE AS NEEDED	PROTECTIVE AS NEEDED

SPECIFICATIONS SUBJECT TO CHANGE WITHOUT NOTICE DIMENSIONS ARE FOR REFERENCE ONLY

				•	
THIRD ANGLE PROJECTION		TITLE	Ø12.5mm, 800nm, HIGH LONGPASS F		CE
ALL DIMS IN	mm	DWG NO	66227		SHEET 1 OF 1

- SUBSTRATE
- 2. SURFACE S2 TO BE PARALLEL WITH SURFACE S1 TO WITHIN 5 arcsec

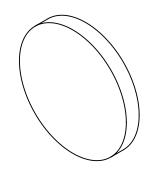
3. COATING (APPLY ACROSS COATING APERTURE)
S1: HARD DIELECTRIC SPUTTERED
T(avg): ≥91% FROM 865 - 1650nm @ 0° AOI
T(avg): ≤0.01% FROM 200 - 835nm @ 0° AOI
T(abs): =50% FOR 850±8.5nm @ 0° AOI

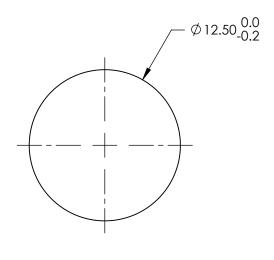
S2:SINGLE LAYER MgF2

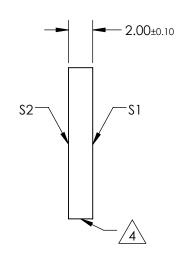
4. FINE GRIND SURFACE

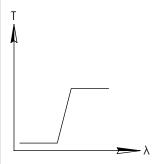
- 5. POWER, IRREGULARITY, AND SURFACE QUALITY SPECIFICATIONS APPLY ACROSS CLEAR APERTURE
- 6. TRANSMITTED WAVEFRONT DISTORTION, RMS: ≤λ/4 @ 633nm
- 7. ROHS COMPLIANT











LONGPASS FILTER

REV A	\$1	\$2
SHAPE	PLANO	PLANO
SURFACE QUALITY	40-20	40-20
CLEAR APERTURE	>80%	>80%
BEVEL	PROTECTIVE AS NEEDED	PROTECTIVE AS NEEDED



THIRD ANGLE PROJECTION		TITLE	Ø12.5mm, 850nm, HIGH PERFORMAI LONGPASS FILTER	NCE
ALL DIMS IN	mm	DWG NO	66228	SHEET 1 OF 1

- SUBSTRATE
- 2. SURFACE S2 TO BE PARALLEL WITH SURFACE S1 TO WITHIN 5 arcsec

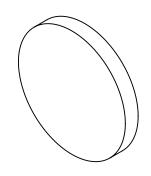
3. COATING (APPLY ACROSS COATING APERTURE)
S1: HARD DIELECTRIC SPUTTERED
T(avg): ≥91% FROM 915 - 1650nm @ 0° AOI
T(avg): ≤0.01% FROM 200 - 880nm @ 0° AOI
T(abs): =50% FOR 900±9nm @ 0° AOI

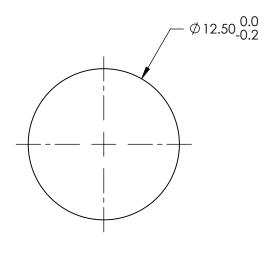
S2:SINGLE LAYER MgF2

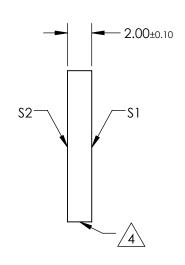
4. FINE GRIND SURFACE

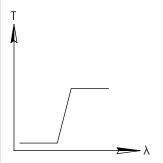
- 5. POWER, IRREGULARITY, AND SURFACE QUALITY SPECIFICATIONS APPLY ACROSS CLEAR APERTURE
- 6. TRANSMITTED WAVEFRONT DISTORTION, RMS: ≤λ/4 @ 633nm
- 7. ROHS COMPLIANT











LONGPASS FILTER

	REV A	\$1	\$2
	SHAPE	PLANO	PLANO
ļ	SURFACE QUALITY	40-20	40-20
	CLEAR APERTURE	>80%	>80%
	BEVEL	PROTECTIVE AS NEEDED	PROTECTIVE AS NEEDED



			-
THIRD ANGLE PROJECTION	\rightarrow	TITLE	Ø12.5mm, 900nm, HIGH PERFORMANCE LONGPASS FILTER
ALL DIMS IN	mm	DWG NO	66229 SHEET

- SUBSTRATE
- 2. SURFACE S2 TO BE PARALLEL WITH SURFACE S1 TO WITHIN 5 arcsec

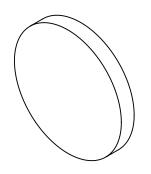
3. COATING (APPLY ACROSS COATING APERTURE)
S1: HARD DIELECTRIC SPUTTERED
T(avg): ≥91% FROM 965 - 1650nm @ 0° AOI
T(avg): ≤0.01% FROM 200 - 930nm @ 0° AOI
T(abs): =50% FOR 950±9.5nm @ 0° AOI

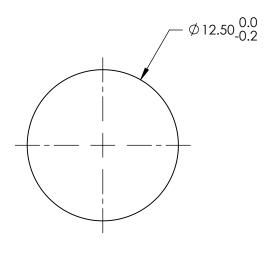
S2:SINGLE LAYER MgF2

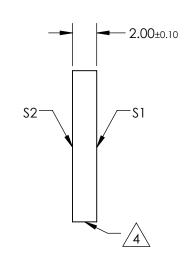
4. FINE GRIND SURFACE

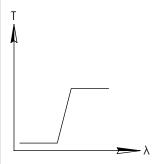
- 5. POWER, IRREGULARITY, AND SURFACE QUALITY SPECIFICATIONS APPLY ACROSS CLEAR APERTURE
- 6. TRANSMITTED WAVEFRONT DISTORTION, RMS: ≤\(\lambda/4\) @ 633nm
- 7. ROHS COMPLIANT











LONGPASS FILTER

REV A	\$1	\$2
SHAPE	PLANO	PLANO
SURFACE QUALITY	40-20	40-20
CLEAR APERTURE	>80%	>80%
BEVEL	PROTECTIVE AS NEEDED	PROTECTIVE AS NEEDED

SPECIFICATIONS SUBJECT TO CHANGE WITHOUT NOTICE DIMENSIONS ARE FOR REFERENCE ONLY

			-	
THIRD ANGLE _ PROJECTION		TITLE	Ø12.5mm, 950nm, HIGH PERFORMANCE LONGPASS FILTER	
ALL DIMS IN	mm	DWG NO	66230 SHEET	

- SUBSTRATE
- 2. SURFACE S2 TO BE PARALLEL WITH SURFACE S1 TO WITHIN 5 arcsec

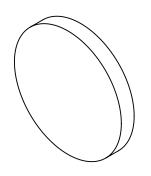
3. COATING (APPLY ACROSS COATING APERTURE)
S1: HARD DIELECTRIC SPUTTERED
T(avg): ≥91% FROM 1020 - 1650nm @ 0° AOI
T(avg):≤0.01% FROM 200 - 980nm @ 0° AOI
T(abs):=50% FOR 1000±10nm @ 0° AOI

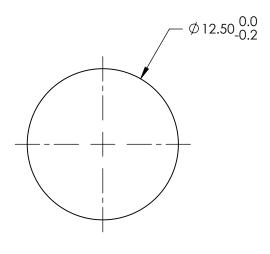
S2:SINGLE LAYER MgF2

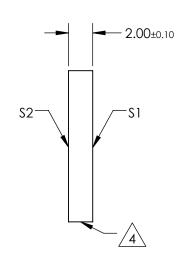
4. FINE GRIND SURFACE

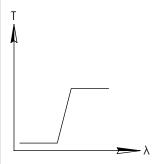
- 5. POWER, IRREGULARITY, AND SURFACE QUALITY SPECIFICATIONS APPLY ACROSS CLEAR APERTURE
- 6. TRANSMITTED WAVEFRONT DISTORTION, RMS: ≤λ/4 @ 633nm
- 7. ROHS COMPLIANT











LONGPASS FILTER

REV A	\$1	\$2
SHAPE	PLANO	PLANO
SURFACE QUALITY	40-20	40-20
CLEAR APERTURE	>80%	>80%
BEVEL	PROTECTIVE AS NEEDED	PROTECTIVE AS NEEDED

SPECIFICATIONS SUBJECT TO CHANGE WITHOUT NOTICE DIMENSIONS ARE FOR REFERENCE ONLY

_				-	
	THIRD ANGLE _ PROJECTION	ϕ	TITLE	Ø12.5mm, 1000nm, HIGH PERFORMAI LONGPASS FILTER	NCE
	ALL DIMS IN	mm	DWG NO	66231	SHEET 1 OF 1

- SUBSTRATE
- 2. SURFACE S2 TO BE PARALLEL WITH SURFACE S1 TO WITHIN 5 arcsec

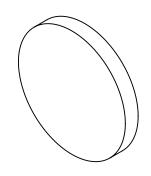
3. COATING (APPLY ACROSS COATING APERTURE)
S1: HARD DIELECTRIC SPUTTERED
T(avg): ≥91% FROM 1070 - 1650nm @ 0° AOI
T(avg):≤0.01% FROM 200 - 1030nm @ 0° AOI
T(abs):=50% FOR 1050±10.5nm @ 0° AOI

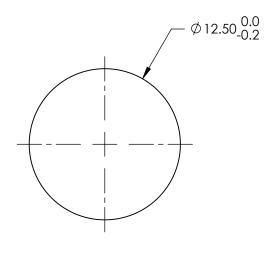
S2:SINGLE LAYER MgF2

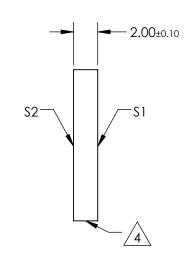
4. FINE GRIND SURFACE

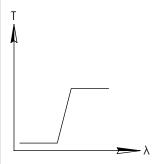
- 5. POWER, IRREGULARITY, AND SURFACE QUALITY SPECIFICATIONS APPLY ACROSS CLEAR APERTURE
- 6. TRANSMITTED WAVEFRONT DISTORTION, RMS: ≤\(\lambda/4\) @ 633nm
- 7. ROHS COMPLIANT











LONGPASS FILTER

REV A	\$1	\$2
SHAPE	PLANO	PLANO
SURFACE QUALITY	40-20	40-20
CLEAR APERTURE	>80%	>80%
BEVEL	PROTECTIVE AS NEEDED	PROTECTIVE AS NEEDED



THIRD ANGLE - PROJECTION	ϕ	TITLE	Ø12.5mm, 1050nm, HIGH PERFORMAI LONGPASS FILTER	NCE
ALL DIMS IN	mm	DWG NO	66232	SHEET 1 OF 1

- SUBSTRATE
- 2. SURFACE S2 TO BE PARALLEL WITH SURFACE S1 TO WITHIN 5 arcsec

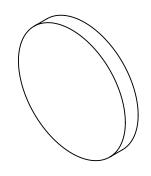
3. COATING (APPLY ACROSS COATING APERTURE)
S1: HARD DIELECTRIC SPUTTERED
T(avg): ≥91% FROM 1120 - 1650nm @ 0° AOI
T(avg):≤0.01% FROM 200 - 1080nm @ 0° AOI
T(abs):=50% FOR 1100±11nm @ 0° AOI

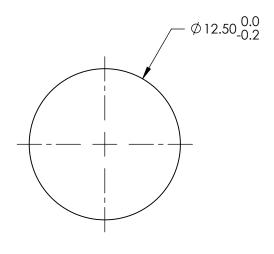
S2:SINGLE LAYER MgF2

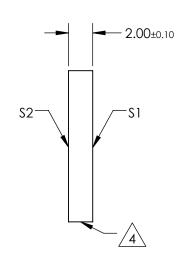
4. FINE GRIND SURFACE

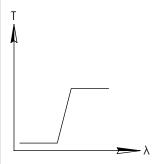
- 5. POWER, IRREGULARITY, AND SURFACE QUALITY SPECIFICATIONS APPLY ACROSS CLEAR APERTURE
- 6. TRANSMITTED WAVEFRONT DISTORTION, RMS: ≤\(\lambda/4\) @ 633nm
- 7. ROHS COMPLIANT











LONGPASS FILTER

REV A	\$1	\$2
SHAPE	PLANO	PLANO
SURFACE QUALITY	40-20	40-20
CLEAR APERTURE	>80%	>80%
BEVEL	PROTECTIVE AS NEEDED	PROTECTIVE AS NEEDED

SPECIFICATIONS SUBJECT TO CHANGE WITHOUT NOTICE DIMENSIONS ARE FOR REFERENCE ONLY

HIRD ANGLE PROJECTION		TITLE	Ø12.5mm, 1100nm, HIGH PERFORMAI LONGPASS FILTER	NCE
ALL DIMS IN	mm	DWG NO	66233	SHEET 1 OF 1

- SUBSTRATE
- 2. SURFACE S2 TO BE PARALLEL WITH SURFACE S1 TO WITHIN 5 arcsec

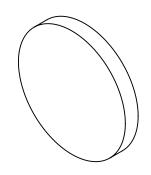
3. COATING (APPLY ACROSS COATING APERTURE)
S1: HARD DIELECTRIC SPUTTERED
T(avg): ≥91% FROM 433 - 1650nm @ 0° AOI
T(avg): ≤0.01% FROM 200 - 415nm @ 0° AOI
T(abs): =50% FOR 425±4.25nm @ 0° AOI

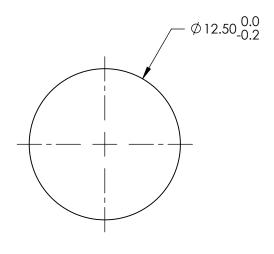
S2:SINGLE LAYER MgF2

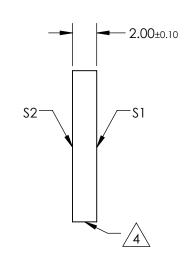
4. FINE GRIND SURFACE

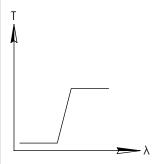
- 5. POWER, IRREGULARITY, AND SURFACE QUALITY SPECIFICATIONS APPLY ACROSS CLEAR APERTURE
- 6. TRANSMITTED WAVEFRONT DISTORTION, RMS: ≤\(\lambda/4\) @ 633nm
- 7. ROHS COMPLIANT











LONGPASS FILTER

REV A	\$1	\$2
SHAPE	PLANO	PLANO
SURFACE QUALITY	40-20	40-20
CLEAR APERTURE	>80%	>80%
BEVEL	PROTECTIVE AS NEEDED	PROTECTIVE AS NEEDED

SPECIFICATIONS SUBJECT TO CHANGE WITHOUT NOTICE DIMENSIONS ARE FOR REFERENCE ONLY

THIRD ANGLE _ PROJECTION	ϕ	TITLE	Ø12.5mm, 425nm, HIGH PERFORMAN LONGPASS FILTER	ICE
ALL DIMS IN	mm	DWG NO	84736	SHEET

- SUBSTRATE
- 2. SURFACE S2 TO BE PARALLEL WITH SURFACE S1 TO WITHIN 5 arcsec

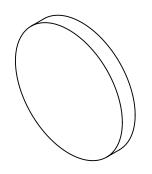
3. COATING (APPLY ACROSS COATING APERTURE)
S1: HARD DIELECTRIC SPUTTERED
T(avg): ≥91% FROM 483 - 1650nm @ 0° AOI
T(avg): ≤0.01% FROM 200 - 465nm @ 0° AOI
T(abs): =50% FOR 475±4.75nm @ 0° AOI

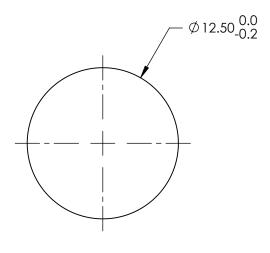
S2:SINGLE LAYER MgF2

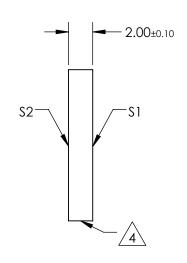
4. FINE GRIND SURFACE

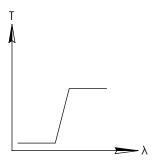
- 5. POWER, IRREGULARITY, AND SURFACE QUALITY SPECIFICATIONS APPLY ACROSS CLEAR APERTURE
- 6. TRANSMITTED WAVEFRONT DISTORTION, RMS: ≤λ/4 @ 633nm
- 7. ROHS COMPLIANT











LONGPASS FILTER

REV A	\$1	\$2
SHAPE	PLANO	PLANO
SURFACE QUALITY	40-20	40-20
CLEAR APERTURE	>80%	>80%
BEVEL	PROTECTIVE AS NEEDED	PROTECTIVE AS NEEDED

SPECIFICATIONS SUBJECT TO CHANGE WITHOUT NOTICE DIMENSIONS ARE FOR REFERENCE ONLY

THIRD ANGLE PROJECTION		TITLE	Ø12.5mm, 475nm, HIGH PERFORMAN LONGPASS FILTER	ICE
ALL DIMS IN	mm	DWG NO	84737	SHEET 1 OF 1

- SUBSTRATE
- 2. SURFACE S2 TO BE PARALLEL WITH SURFACE S1 TO WITHIN 5 arcsec

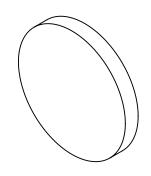
3. COATING (APPLY ACROSS COATING APERTURE)
S1: HARD DIELECTRIC SPUTTERED
T(avg): ≥91% FROM 534 - 1650nm @ 0° AOI
T(avg): ≤0.01% FROM 200 - 515nm @ 0° AOI
T(abs): =50% FOR 525±5.25nm @ 0° AOI

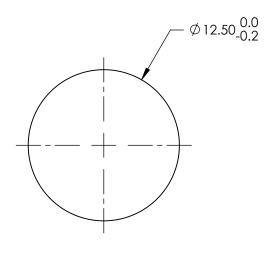
S2:SINGLE LAYER MgF2

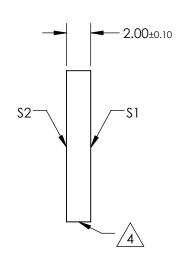
4. FINE GRIND SURFACE

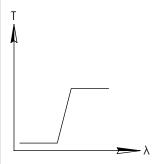
- 5. POWER, IRREGULARITY, AND SURFACE QUALITY SPECIFICATIONS APPLY ACROSS CLEAR APERTURE
- 6. TRANSMITTED WAVEFRONT DISTORTION, RMS: ≤λ/4 @ 633nm
- 7. ROHS COMPLIANT











LONGPASS FILTER

REV A	\$1	\$2
SHAPE	PLANO	PLANO
SURFACE QUALITY	40-20	40-20
CLEAR APERTURE	>80%	>80%
BEVEL	PROTECTIVE AS NEEDED	PROTECTIVE AS NEEDED

SPECIFICATIONS SUBJECT TO CHANGE WITHOUT NOTICE DIMENSIONS ARE FOR REFERENCE ONLY

			<u> </u>	
THIRD ANGLE - PROJECTION	\rightarrow	TITLE	Ø12.5mm, 525nm, HIGH PERFORMANCE LONGPASS FILTER	
ALL DIMS IN	mm	DWG NO	84738 SHE	ET OF 1

- SUBSTRATE
- 2. SURFACE S2 TO BE PARALLEL WITH SURFACE S1 TO WITHIN 5 arcsec

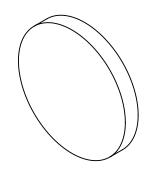
3. COATING (APPLY ACROSS COATING APERTURE)
S1: HARD DIELECTRIC SPUTTERED
T(avg): ≥91% FROM 585 - 1650nm @ 0° AOI
T(avg): ≤0.01% FROM 200 - 564nm @ 0° AOI
T(abs): =50% FOR 575±5.75nm @ 0° AOI

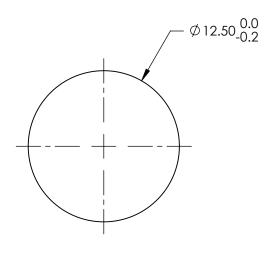
S2:SINGLE LAYER MgF2

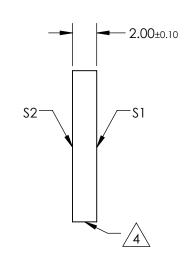
4. FINE GRIND SURFACE

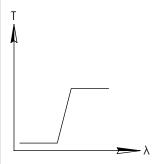
- 5. POWER, IRREGULARITY, AND SURFACE QUALITY SPECIFICATIONS APPLY ACROSS CLEAR APERTURE
- 6. TRANSMITTED WAVEFRONT DISTORTION, RMS: ≤λ/4 @ 633nm
- 7. ROHS COMPLIANT











LONGPASS FILTER

REV A	\$1	\$2
SHAPE	PLANO	PLANO
SURFACE QUALITY	40-20	40-20
CLEAR APERTURE	>80%	>80%
BEVEL	PROTECTIVE AS NEEDED	PROTECTIVE AS NEEDED



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THIRD ANGLE PROJECTION	\rightarrow	TITLE	Ø12.5mm, 575nm, HIGH PERFORMANCE LONGPASS FILTER
ALL DIMS IN	mm	DWG NO	84739 SHEET

- SUBSTRATE
- 2. SURFACE S2 TO BE PARALLEL WITH SURFACE S1 TO WITHIN 5 arcsec

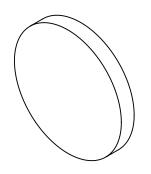
3. COATING (APPLY ACROSS COATING APERTURE)
S1: HARD DIELECTRIC SPUTTERED
T(avg): ≥91% FROM 635 - 1650nm @ 0° AOI
T(avg): ≤0.01% FROM 200 - 613nm @ 0° AOI
T(abs): =50% FOR 625±6.25nm @ 0° AOI

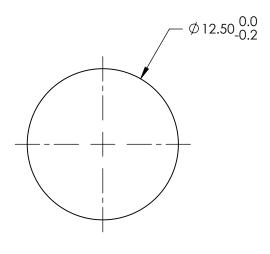
S2:SINGLE LAYER MgF2

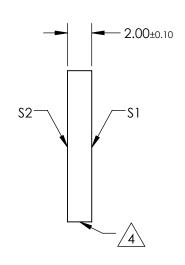
4. FINE GRIND SURFACE

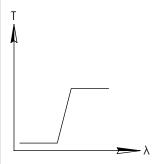
- 5. POWER, IRREGULARITY, AND SURFACE QUALITY SPECIFICATIONS APPLY ACROSS CLEAR APERTURE
- 6. TRANSMITTED WAVEFRONT DISTORTION, RMS: ≤λ/4 @ 633nm
- 7. ROHS COMPLIANT











LONGPASS FILTER

REV A	\$1	\$2
SHAPE	PLANO	PLANO
SURFACE QUALITY	40-20	40-20
CLEAR APERTURE	>80%	>80%
BEVEL	PROTECTIVE AS NEEDED	PROTECTIVE AS NEEDED

SPECIFICATIONS SUBJECT TO CHANGE WITHOUT NOTICE DIMENSIONS ARE FOR REFERENCE ONLY

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THIRD ANGLE PROJECTION	\rightarrow	TITLE		n, HIGH PERFORMANCE SPASS FILTER	
ALL DIMS IN	mm	DWG NO	84740	SH 10	HEET OF 1

- SUBSTRATE
- 2. SURFACE S2 TO BE PARALLEL WITH SURFACE S1 TO WITHIN 5 arcsec

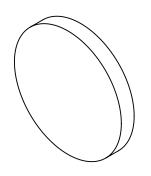
3. COATING (APPLY ACROSS COATING APERTURE)
S1: HARD DIELECTRIC SPUTTERED
T(avg): ≥91% FROM 685 - 1650nm @ 0° AOI
T(avg): ≤0.01% FROM 200 - 662nm @ 0° AOI
T(abs): =50% FOR 675±6.75nm @ 0° AOI

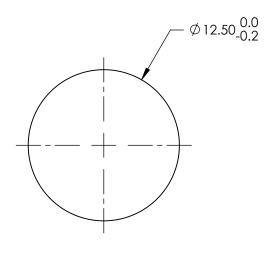
S2:SINGLE LAYER MgF2

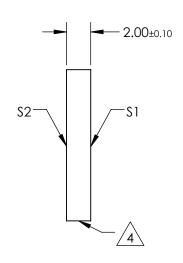
4. FINE GRIND SURFACE

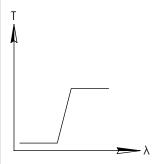
- 5. POWER, IRREGULARITY, AND SURFACE QUALITY SPECIFICATIONS APPLY ACROSS CLEAR APERTURE
- 6. TRANSMITTED WAVEFRONT DISTORTION, RMS: ≤λ/4 @ 633nm
- 7. ROHS COMPLIANT











LONGPASS FILTER

REV A	\$1	\$2
SHAPE	PLANO	PLANO
SURFACE QUALITY	40-20	40-20
CLEAR APERTURE	>80%	>80%
BEVEL	PROTECTIVE AS NEEDED	PROTECTIVE AS NEEDED



			•
THIRD ANGLE - PROJECTION	\rightarrow	TITLE	Ø12.5mm, 675nm, HIGH PERFORMANCE LONGPASS FILTER
ALL DIMS IN	mm	DWG NO	84741 SHEET 1 OF 1

- SUBSTRATE
- 2. SURFACE S2 TO BE PARALLEL WITH SURFACE S1 TO WITHIN 5 arcsec

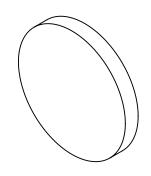
3. COATING (APPLY ACROSS COATING APERTURE)
S1: HARD DIELECTRIC SPUTTERED
T(avg): ≥91% FROM 735 - 1650nm @ 0° AOI
T(avg): ≤0.01% FROM 200 - 705nm @ 0° AOI
T(abs): =50% FOR 725±7.25nm @ 0° AOI

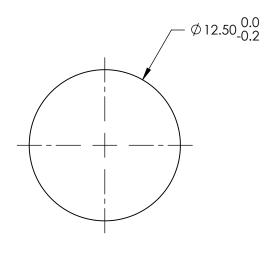
S2:SINGLE LAYER MgF2

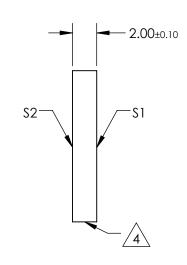
4. FINE GRIND SURFACE

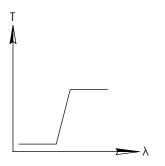
- 5. POWER, IRREGULARITY, AND SURFACE QUALITY SPECIFICATIONS APPLY ACROSS CLEAR APERTURE
- 6. TRANSMITTED WAVEFRONT DISTORTION, RMS: ≤\(\lambda/4\) @ 633nm
- 7. ROHS COMPLIANT











LONGPASS FILTER

REV A	\$1	\$2
SHAPE	PLANO	PLANO
SURFACE QUALITY	40-20	40-20
CLEAR APERTURE	>80%	>80%
BEVEL	PROTECTIVE AS NEEDED	PROTECTIVE AS NEEDED



			•
THIRD ANGLE - PROJECTION	$\phi \Leftrightarrow$	TITLE	Ø12.5mm, 725nm, HIGH PERFORMANCE LONGPASS FILTER
ALL DIMS IN	mm	DWG NO	86060 SHEET

- SUBSTRATE
- 2. SURFACE S2 TO BE PARALLEL WITH SURFACE S1 TO WITHIN 5 arcsec

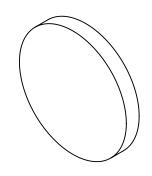
3. COATING (APPLY ACROSS COATING APERTURE)
S1: HARD DIELECTRIC SPUTTERED
T(avg): ≥91% FROM 790 - 1650nm @ 0° AOI
T(avg): ≤0.01% FROM 200 - 760nm @ 0° AOI
T(abs): =50% FOR 775±7.75nm @ 0° AOI

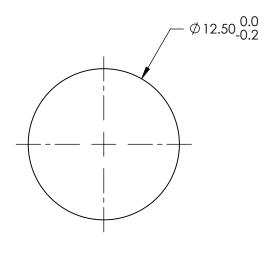
S2:SINGLE LAYER MgF2

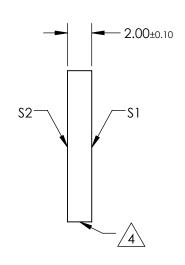
4. FINE GRIND SURFACE

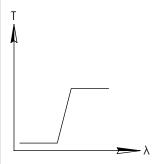
- 5. POWER, IRREGULARITY, AND SURFACE QUALITY SPECIFICATIONS APPLY ACROSS CLEAR APERTURE
- 6. TRANSMITTED WAVEFRONT DISTORTION, RMS: ≤\(\lambda/4\) @ 633nm
- 7. ROHS COMPLIANT











LONGPASS FILTER

REV A	\$1	\$2
SHAPE	PLANO	PLANO
SURFACE QUALITY	40-20	40-20
CLEAR APERTURE	>80%	>80%
BEVEL	PROTECTIVE AS NEEDED	PROTECTIVE AS NEEDED

SPECIFICATIONS SUBJECT TO CHANGE WITHOUT NOTICE DIMENSIONS ARE FOR REFERENCE ONLY

Ran® Edmund Optics®

THIRD ANGLE PROJECTION	\rightarrow	TITLE	Ø12.5mm, 775nm, HIGH PERFORMAN LONGPASS FILTER	ICE
ALL DIMS IN	mm	DWG NO	86061	SHEET 1 OF 1

- SUBSTRATE
- 2. SURFACE S2 TO BE PARALLEL WITH SURFACE S1 TO WITHIN 5 arcsec

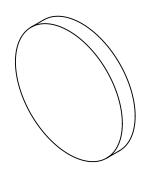
3. COATING (APPLY ACROSS COATING APERTURE)
S1: HARD DIELECTRIC SPUTTERED
T(avg): ≥91% FROM 840 - 1650nm @ 0° AOI
T(avg): ≤0.01% FROM 200 - 805nm @ 0° AOI
T(abs): =50% FOR 825±8.25nm @ 0° AOI

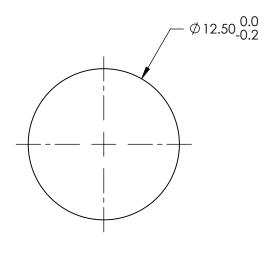
S2:SINGLE LAYER MgF2

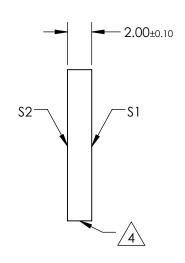
4. FINE GRIND SURFACE

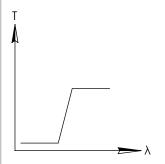
- 5. POWER, IRREGULARITY, AND SURFACE QUALITY SPECIFICATIONS APPLY ACROSS CLEAR APERTURE
- 6. TRANSMITTED WAVEFRONT DISTORTION, RMS: ≤\(\lambda/4\) @ 633nm
- 7. ROHS COMPLIANT











LONGPASS FILTER

REV A	\$1	\$2
SHAPE	PLANO	PLANO
SURFACE QUALITY	40-20	40-20
CLEAR APERTURE	>80%	>80%
BEVEL	PROTECTIVE AS NEEDED	PROTECTIVE AS NEEDED



			•
THIRD ANGLE - PROJECTION	\rightarrow	TITLE	Ø12.5mm, 825nm, HIGH PERFORMANCE LONGPASS FILTER
ALL DIMS IN	mm	DWG NO	86062 SHEET

- SUBSTRATE
- 2. SURFACE S2 TO BE PARALLEL WITH SURFACE S1 TO WITHIN 5 arcsec

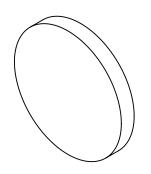
3. COATING (APPLY ACROSS COATING APERTURE)
S1: HARD DIELECTRIC SPUTTERED
T(avg): ≥91% FROM 890 - 1650nm @ 0° AOI
T(avg): ≤0.01% FROM 200 - 860nm @ 0° AOI
T(abs): =50% FOR 875±8.75nm @ 0° AOI

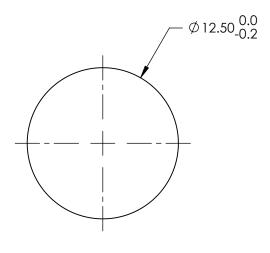
S2:SINGLE LAYER MgF2

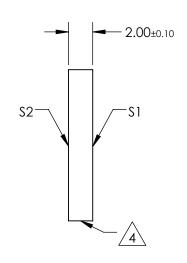
4. FINE GRIND SURFACE

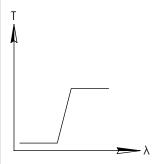
- 5. POWER, IRREGULARITY, AND SURFACE QUALITY SPECIFICATIONS APPLY ACROSS CLEAR APERTURE
- 6. TRANSMITTED WAVEFRONT DISTORTION, RMS: ≤λ/4 @ 633nm
- 7. ROHS COMPLIANT











LONGPASS FILTER

REV A	\$1	\$2
SHAPE	PLANO	PLANO
SURFACE QUALITY	40-20	40-20
CLEAR APERTURE	>80%	>80%
BEVEL	PROTECTIVE AS NEEDED	PROTECTIVE AS NEEDED

SPECIFICATIONS SUBJECT TO CHANGE WITHOUT NOTICE DIMENSIONS ARE FOR REFERENCE ONLY

HIRD ANGLE TITLE		TITLE	Ø12.5mm, 875nm, HIGH PERFORMAN LONGPASS FILTER	ICE
ALL DIMS IN	mm	DWG NO	86063	SHEET

- SUBSTRATE
- 2. SURFACE S2 TO BE PARALLEL WITH SURFACE S1 TO WITHIN 5 arcsec

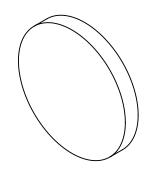
3. COATING (APPLY ACROSS COATING APERTURE)
S1: HARD DIELECTRIC SPUTTERED
T(avg): ≥91% FROM 940 - 1650nm @ 0° AOI
T(avg): ≤0.01% FROM 200 - 905nm @ 0° AOI
T(abs): =50% FOR 925±9.25nm @ 0° AOI

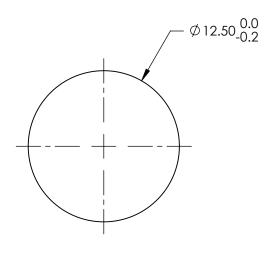
S2:SINGLE LAYER MgF2

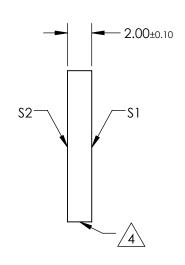
4. FINE GRIND SURFACE

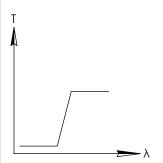
- 5. POWER, IRREGULARITY, AND SURFACE QUALITY SPECIFICATIONS APPLY ACROSS CLEAR APERTURE
- 6. TRANSMITTED WAVEFRONT DISTORTION, RMS: ≤\(\lambda/4\) @ 633nm
- 7. ROHS COMPLIANT











LONGPASS FILTER

REV A	\$1	\$2
SHAPE	PLANO	PLANO
SURFACE QUALITY	40-20	40-20
CLEAR APERTURE	>80%	>80%
BEVEL	PROTECTIVE AS NEEDED	PROTECTIVE AS NEEDED

SPECIFICATIONS SUBJECT TO CHANGE WITHOUT NOTICE DIMENSIONS ARE FOR REFERENCE ONLY

Ran® Edmund Optics®

			•
THIRD ANGLE PROJECTION	\rightarrow	TITLE	Ø12.5mm, 925nm, HIGH PERFORMANCE LONGPASS FILTER
ALL DIMS IN	mm	DWG NO	86064 SHEET

- SUBSTRATE
- 2. SURFACE S2 TO BE PARALLEL WITH SURFACE S1 TO WITHIN 5 arcsec

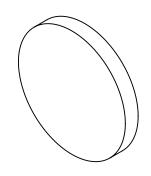
3. COATING (APPLY ACROSS COATING APERTURE)
S1: HARD DIELECTRIC SPUTTERED
T(avg): ≥91% FROM 990 - 1650nm @ 0° AOI
T(avg): ≤0.01% FROM 200 - 955nm @ 0° AOI
T(abs): =50% FOR 975±9.75nm @ 0° AOI

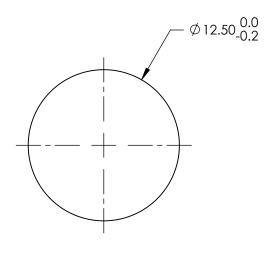
S2:SINGLE LAYER MgF2

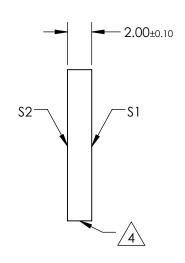
4. FINE GRIND SURFACE

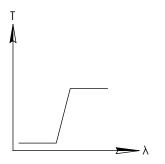
- 5. POWER, IRREGULARITY, AND SURFACE QUALITY SPECIFICATIONS APPLY ACROSS CLEAR APERTURE
- 6. TRANSMITTED WAVEFRONT DISTORTION, RMS: ≤λ/4 @ 633nm
- 7. ROHS COMPLIANT











LONGPASS FILTER

REV A	\$1	\$2
SHAPE	PLANO	PLANO
SURFACE QUALITY	40-20	40-20
CLEAR APERTURE	>80%	>80%
BEVEL	PROTECTIVE AS NEEDED	PROTECTIVE AS NEEDED



			•
THIRD ANGLE - PROJECTION		TITLE	Ø12.5mm, 975nm, HIGH PERFORMANCE LONGPASS FILTER
ALL DIMS IN	mm	DWG NO	86065 SHEET 1.0F.1

- SUBSTRATE
- 2. SURFACE S2 TO BE PARALLEL WITH SURFACE S1 TO WITHIN 5 arcsec

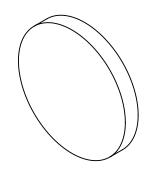
3. COATING (APPLY ACROSS COATING APERTURE)
S1: HARD DIELECTRIC SPUTTERED
T(avg): ≥91% FROM 1045 - 1650nm @ 0° AOI
T(avg):≤0.01% FROM 200 - 1005nm @ 0° AOI
T(abs):=50% FOR 1025±10.25nm @ 0° AOI

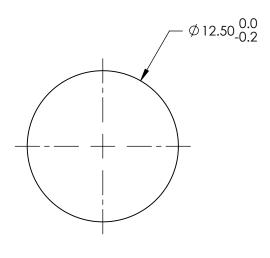
S2:SINGLE LAYER MgF2

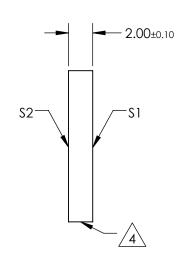
4. FINE GRIND SURFACE

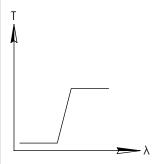
- 5. POWER, IRREGULARITY, AND SURFACE QUALITY SPECIFICATIONS APPLY ACROSS CLEAR APERTURE
- 6. TRANSMITTED WAVEFRONT DISTORTION, RMS: ≤\(\lambda/4\) @ 633nm
- 7. ROHS COMPLIANT











LONGPASS FILTER

REV A	\$1	\$2
SHAPE	PLANO	PLANO
SURFACE QUALITY	40-20	40-20
CLEAR APERTURE	>80%	>80%
BEVEL	PROTECTIVE AS NEEDED	PROTECTIVE AS NEEDED

SPECIFICATIONS SUBJECT TO CHANGE WITHOUT NOTICE DIMENSIONS ARE FOR REFERENCE ONLY

THIRD ANGLE _ PROJECTION		TITLE	Ø12.5mm, 1025nm, HIGH PERFORMAI LONGPASS FILTER	NCE
ALL DIMS IN	mm	DWG NO	86066	SHEET

- SUBSTRATE
- 2. SURFACE S2 TO BE PARALLEL WITH SURFACE S1 TO WITHIN 5 arcsec

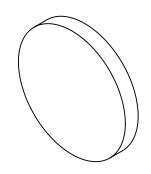
3. COATING (APPLY ACROSS COATING APERTURE)
S1: HARD DIELECTRIC SPUTTERED
T(avg): ≥91% FROM 1095 - 1650nm @ 0° AOI
T(avg): ≤0.01% FROM 200 - 1055nm @ 0° AOI
T(abs): =50% FOR 1075±10.75nm @ 0° AOI

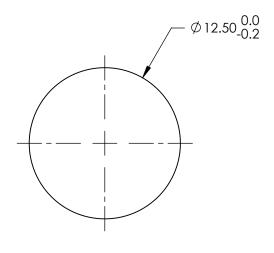
S2:SINGLE LAYER MgF2

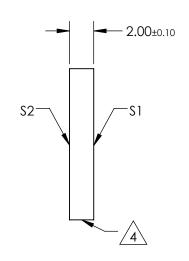
4. FINE GRIND SURFACE

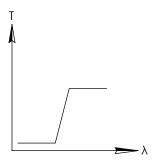
- 5. POWER, IRREGULARITY, AND SURFACE QUALITY SPECIFICATIONS APPLY ACROSS CLEAR APERTURE
- 6. TRANSMITTED WAVEFRONT DISTORTION, RMS: ≤λ/4 @ 633nm
- 7. ROHS COMPLIANT











LONGPASS FILTER

REV A	\$1	\$2
SHAPE	PLANO	PLANO
SURFACE QUALITY	40-20	40-20
CLEAR APERTURE	>80%	>80%
BEVEL	PROTECTIVE AS NEEDED	PROTECTIVE AS NEEDED

SPECIFICATIONS SUBJECT TO CHANGE WITHOUT NOTICE DIMENSIONS ARE FOR REFERENCE ONLY

			-	
HIRD ANGLE - PROJECTION	ϕ	TITLE	Ø12.5mm, 1075nm, HIGH PERFORMA LONGPASS FILTER	NCE
all DIMS IN	mm	DWG NO	86067	SHEET 1 OF 1